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CLAIM AMENDMENTS

1. (Original) An optical emission analysis system configured for use with a source of excitation energy and a spectrograph including an image sensor having an array of pixels, the system comprising:

a probe for collecting optical sample data;

- a source of calibration light; and
- optical elements for directing the optical sample data and calibration light to the spectrograph so that adjacent data and calibration channels are formed on the image sensor.
- 2. (Original) The system of claim 1, wherein the optical sample data is representative of a Raman or fluorescence emission.
- 3. (Original) The system of claim 1, wherein each data channel is bounded on either side by an adjacent calibration channel.
- 4. (Original) The system of claim 1, wherein:
 each data channel is bounded on either side by an adjacent calibration channel; and interpolation is used between the calibration channels to determine the wavelength calibration of the data channel.
- 5. (Original) The system of claim 1, wherein the optical sample data is dispersed by a plurality of optical gratings such that higher and lower frequency components form different data channels on the image sensor, each adjacent to a calibration channel.
- 6. (Original) The system of claim 1, further including a broadband source of light that may be selectively directed onto the image sensor to directly determine binning ranges of calibration channels.

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- 7. (Original) The system of claim 6, wherein the binning ranges or data channels are determined by interpolation of the calibration channel binning.
 - 8. (Original) The system of claim 1, further including:
 - a plurality of remote optical measurement probes; and
- a plurality of optical switches for routing optical sample data from each probe to the spectrograph on a selective basis.
 - 9. (Original) The system of claim 1, further including:
 - a plurality of remote optical measurement probes; and
- a plurality of optical switches for routing optical sample data from each probe to the spectrograph on a simultaneous or sequential basis.
 - 10. (Original) The system of claim 1, further including:a plurality of lasers; andoptical switches for routing the light from the lasers to the probe on a selective basis.
- 11. (Original) The system of claim 1, wherein the data and calibration channels are tilted relative to the array of pixels.
 - 12. (Original) The system of claim 1, further including: a laser source; and

optical switches for:

- a) selectively routing light from the laser source to a material having a known spectral response relative to the laser, and
- b) selectively routing the known spectral response to the spectrograph for use as a laser wavelength calibration channel.
- 13. (Original) The system of claim 12, wherein the optical switches may be configured for use as laser shutter.

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- 14. (Original) The system of claim 12, wherein the material having a known spectral response is an edge-illuminated diamond wafer.
- 15. (Original) The system of claim 1, further including optical detectors at points where optical leakage may occur to provide system status or diagnostic information.
- 16. (Original) The system of claim 15, wherein the points where optical leakage may occur include optical fibers with controlled bends.
 - 17. (Original) The system of claim 1, further including:

an intrinsically safe laser interlock circuit carrying a limited current to and from the optical measurement probe using wires cabled with the optical fibers to monitor the integrity of the cable link; and

an optical illuminator disposed at the location of the probe and connected to the circuit to simultaneously monitor optical path integrity and provide a visual indicator at a probe.

- 18. (Original) An optical emission analysis system configured for use with a source of excitation energy and a spectrograph including an image sensor having an array of pixels, the system comprising:
 - a probe for collecting optical sample data;
 - a source of calibration light;
- a plurality of optical gratings operative to disperse the optical sample data into higher and lower frequency components that form different data channels on the image sensor; and
- optical elements for directing the calibration light to the spectrograph so that the data channels are between calibration channels.
- 19. (Original) The system of claim 18, wherein the data and calibration channels are tilted relative to the array of pixels.

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- 20. (Original) The system of claim 19, further including a broadband source of light that may be selectively directed onto the image sensor to define calibration channel binning.
- 21. (Original) The system of claim 20, wherein the binning ranges or data channels are determined by interpolation of the calibration channel binning.
- 22. (Currently Amended) An optical emission analysis system configured for use with a laser source of excitation energy and a spectrograph including an image sensor having an array of pixels, the system comprising:
 - a probe for collecting optical sample data; [[and]]
- a piece of diamond other material having a known spectral response relative to the laser, the piece being in the form of a flat sample having opposing surface areas and a peripheral edge with a height substantially smaller that the surface areas; and
- a source of laser calibration wavelength light derived by [[cdge-]] illuminating a diamond the edge of the sample or-other-material having a known-spectral-response-relative-to-the-laser.
 - 23. (Original) The system of claim 22, further including:
 - a first optical fiber for delivering the excitation energy to the edge of the material; and
 - a second optical fiber for carrying the known spectral response to the spectrograph.
- 24. (Original) The system of claim 22, further including an optical detector in proximity to the reference material for gathering at least a portion of the laser illumination to maximize laser intensity.
- 25. (Original) An optical emission analysis system configured for use with a source of excitation energy and a spectrograph including an image sensor having an array of pixels, the system comprising:
 - a probe for collecting optical sample data;
 - a source or calibration light;

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optical elements for directing the optical sample data and calibration light to the spectrograph so that multiple channels are formed on the image sensor;

a broadband light source; and

one or more optical switches for routing the broadband light onto the image sensor to determine channel binning.

- 26. (Original) The system of claim 25, further including:
- a plurality of optical gratings operative to disperse the optical sample data into higher and lower frequency components that form different data channels on the image sensor.
- 27. (Original) The system of claim 26, wherein the data and calibration channels are tilted relative to the array of pixels.
- 28. (Original) The system of claim 25, wherein the data and calibration channels are interleaved.